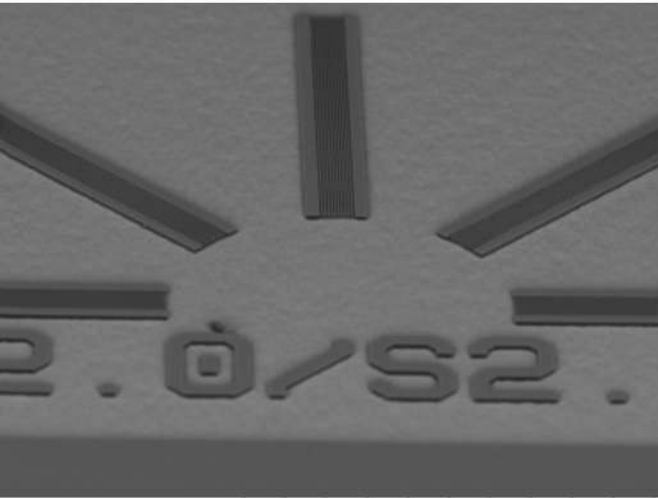


二流体現像機

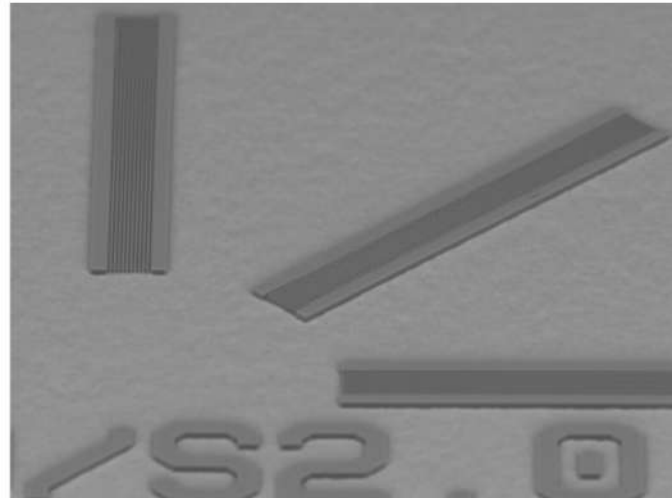
(特許取得済)

スプレー技術

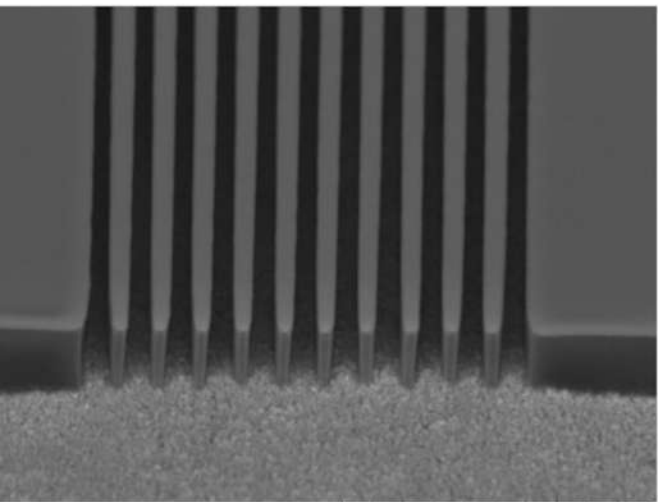
二流体現像処理によるSEM写真(L/S=2/2)



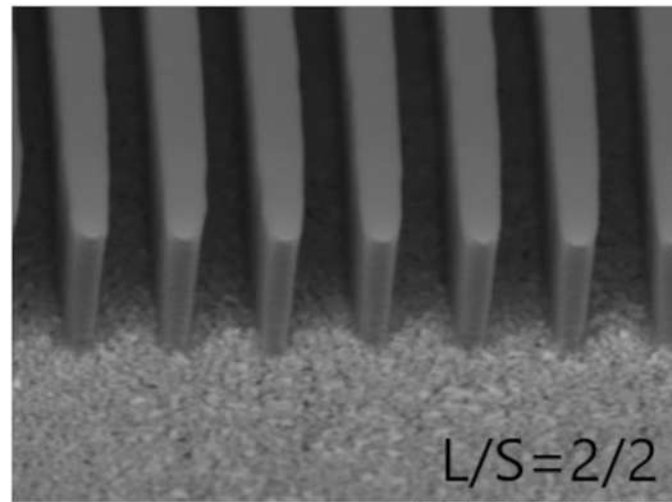
Miniscope2617 2024/12/03 15:10 H D8.0 x200 500 μm



Miniscope2634 2024/12/03 16:42 H D8.2 x250 300 μm



Miniscope2628 2024/12/03 16:33 H D8.2 x2.5k 30 μm



Miniscope2620 2024/12/03 15:22 H D7.8 x6.0k 10 μm

露光装置：(株) LE-TECHNOLOGY製ダイレクト露光装置LAMBDI0602